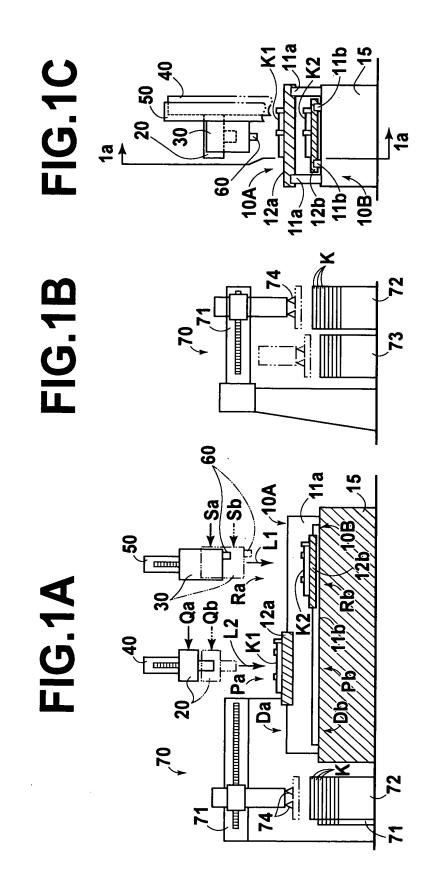
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FIG.2

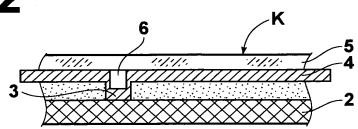
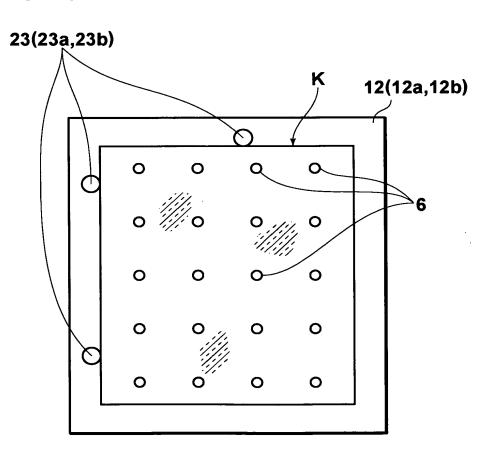


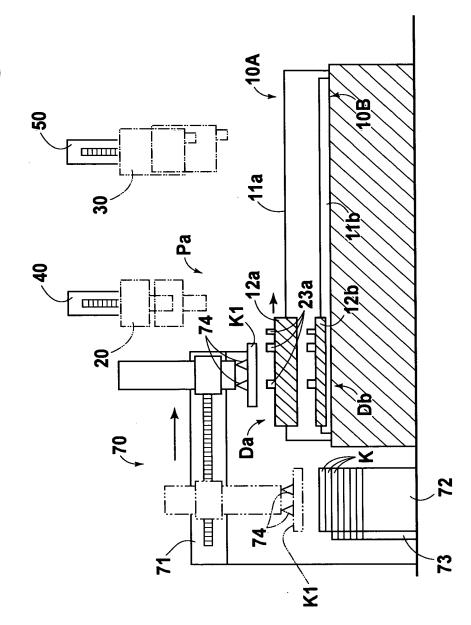
FIG.3

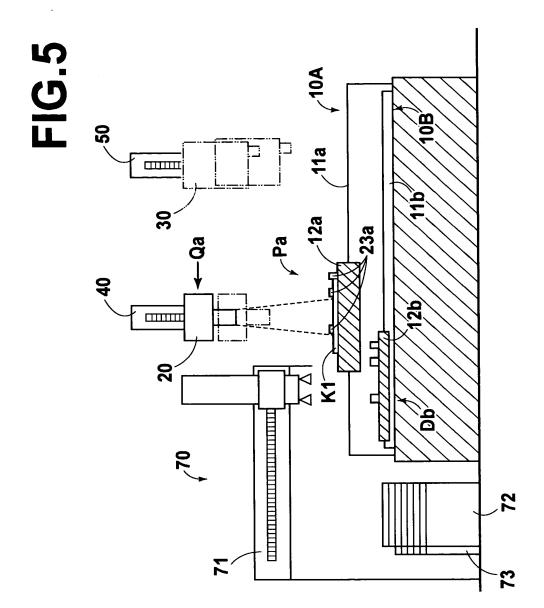


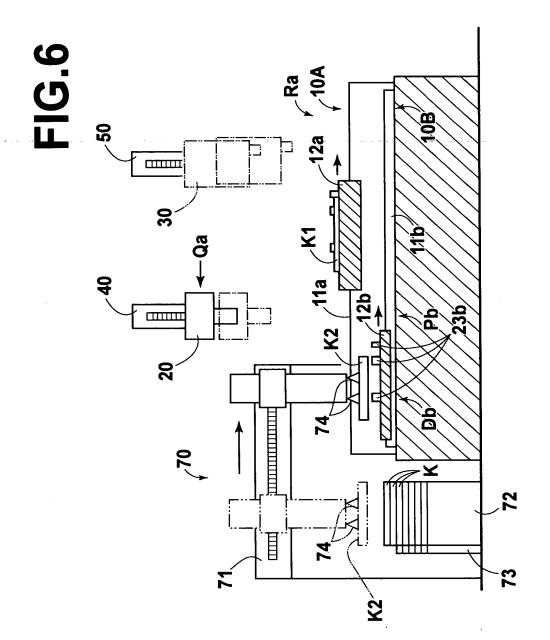
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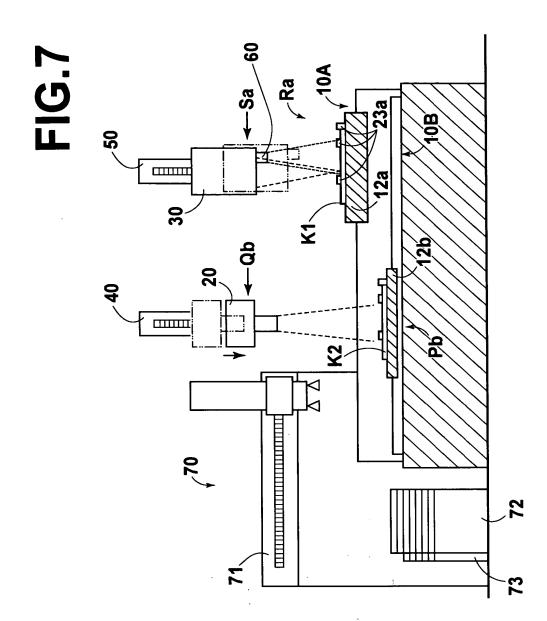
FIG.4







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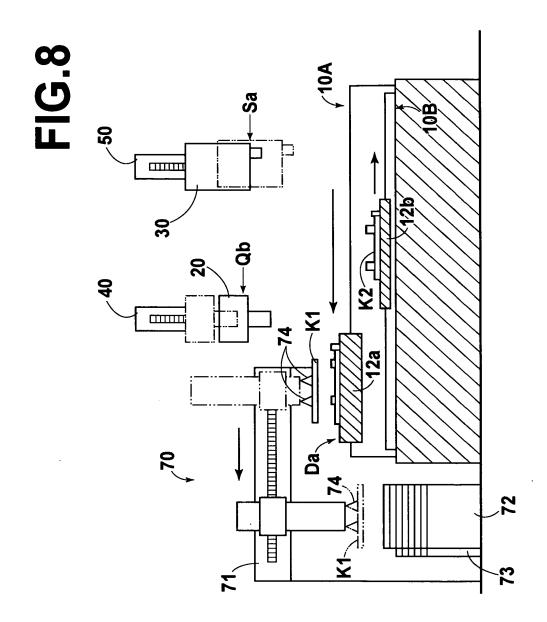


FIG.9 шш

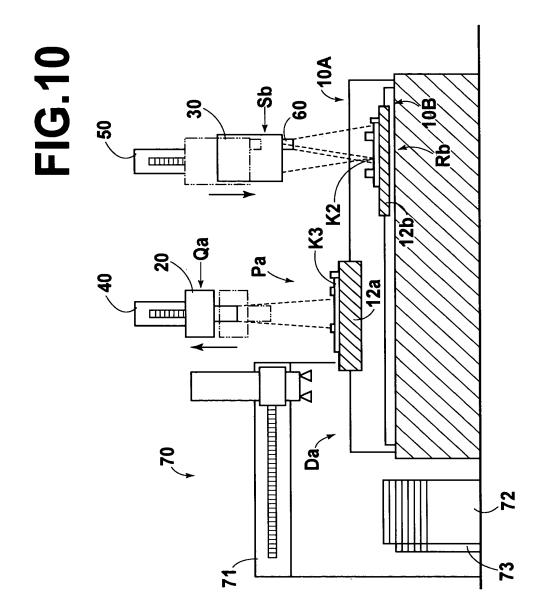


FIG.11 шш ШШ

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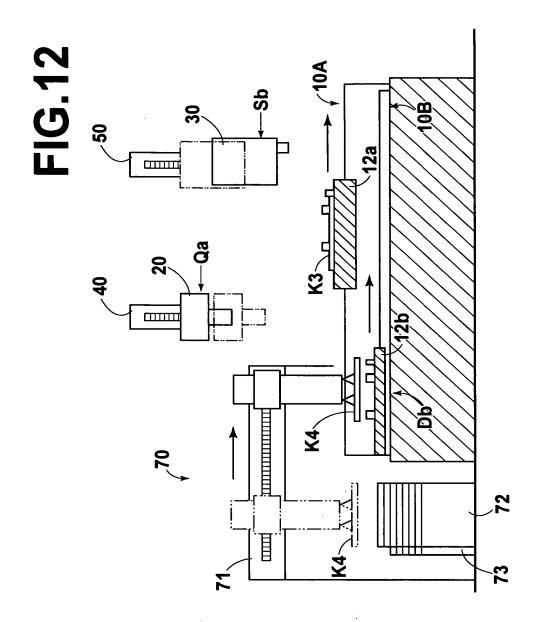


FIG.13

<u> </u>												
STRATE K3	SUPPLY SUBSTRATE K5	(9)(REDOVER MOUNT SUBSTRATE SUBSTRATE K3				TRANSPORT	SUBSTRATE K4				
RECOVER SUBSTRATE K3		(®(SIMILAR TO@)			SUBSTRATEK3		SUBSTRATE K4			MEASURE SUBSTRATE K4	EXPOSE SUBSTRATE K3	
		(D) (D)		TRANSPORT	SUBSTRATEK3	RECOVER MOUNT SUBSTRATE SUBSTRATE K2						
RECOVER SUBSTRATE K2 SUPPLY SUBSTRATE K3		9		Substrate K3				Substrate K2	MEASURE SUBSTRATE K3			EXPOSE SUBSTRATE K2
		9 9	RECOVER MOUNT SUBSTRATE SUBSTRATE K1		The second secon		TRANSPORT	SUBSTRATEK2				
RECOVER SUBSTRATE KI SSTRATE K2		(4)	#BSZ		Substrate K1		SUBSTRATE K2			MEASURE Substrate K2	EXPOSE SUBSTRATE K1	
RECOVERS SUPPLY SUBSTRATE K2		(i)		TRANSPORT	SUBSITAILE K1	MOUNT SUBSTRATE K2	<u> </u>				HO) ¥	
SUPPLY SUBSTRATE K1		0		SUBSTRATE K1		WAITING			MEASURE SUBSTRATE K1			
SUPPLYSU		0	MOUNT SUBSTRATE K1			WAITING						
SUPPLY/ RECOVERY OF	SUBSTRATE	STEPS	SUBSTRATE ATTACHING/ DETACHING POSITION Da	MEASUREMENT POSMON Pa	EXPOSURE POSITION PID	SUBSTRATE ATTACHING/ DETACHING POSITION DD	MEASUREMENT POSMON Po	EXPOSURE POSMON Rb	SUBSTRATE- MEASURING POSITION Qa	SUBSTRATE. MEASURING POSITION OD	SUBSTRATE- EXPOSING POSITION Qa	SUBSTRATE- EXPOSING POSITION Q
SUBSTRATE SUPPLY RECOVERY	DEVICE]] 	POSITION OF SUBSTRATE TRANSPORT MEANS A			POSITION OF SUBSTRATE TRANSPORT MEANS B			SUBSTRATE- MEASURING POSITION OB MEASURING SUBSTRATE- HEAD MEASURING POSITION OB		POSTION OF EXPOSURE HEAD	